



US009709854B2

(12) **United States Patent**
Hirota et al.

(10) **Patent No.:** **US 9,709,854 B2**
(45) **Date of Patent:** **Jul. 18, 2017**

(54) **LIQUID CRYSTAL DISPLAY DEVICE**

(56) **References Cited**

(71) Applicant: **Japan Display Inc.**, Tokyo (JP)

U.S. PATENT DOCUMENTS

(72) Inventors: **Takenori Hirota**, Tokyo (JP); **Yasuhiro Kanaya**, Tokyo (JP); **Hidehiro Sonoda**, Tokyo (JP); **Toshiki Kaneko**, Tokyo (JP)

6,057,038 A * 5/2000 Terashita B08B 7/0057
252/299.01
6,608,660 B1 * 8/2003 Okamoto G02F 1/133512
349/106
2015/0301370 A1 * 10/2015 Moriwaki G02F 1/1339
349/42

(73) Assignee: **Japan Display Inc.**, Tokyo (JP)

FOREIGN PATENT DOCUMENTS

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 77 days.

JP H10-206871 A 8/1998
JP 2012-189856 A 10/2012

* cited by examiner

(21) Appl. No.: **14/720,381**

Primary Examiner — Timothy L Rude

(22) Filed: **May 22, 2015**

(74) *Attorney, Agent, or Firm* — Typha IP LLC

(65) **Prior Publication Data**

US 2015/0346556 A1 Dec. 3, 2015

(30) **Foreign Application Priority Data**

May 28, 2014 (JP) 2014-110118

(51) **Int. Cl.**

G02F 1/1339 (2006.01)

G02F 1/1333 (2006.01)

(52) **U.S. Cl.**

CPC **G02F 1/1339** (2013.01); **G02F 1/133345**
(2013.01); **G02F 2001/133388** (2013.01)

(58) **Field of Classification Search**

CPC G02F 1/1339; G02F 2001/13415
See application file for complete search history.

(57) **ABSTRACT**

A reliability of seal portion of a liquid crystal display device can be improved by the following structure. A liquid crystal display device includes: a TFT substrate which includes a display region and a terminal part, and has an inorganic insulating film formed on an organic passivation film and an alignment film formed over the inorganic insulating film; a counter substrate, the TFT substrate and the counter substrate bonded together by a sealing material formed at a seal part surrounding the display region; and a liquid crystal sealed inside. At the seal part, a transparent conductive oxide film is formed between the inorganic insulating film and the alignment film. The transparent conductive oxide film exists inside an edge of the TFT substrate and hence, the edge of the TFT substrate is free of the transparent conductive oxide film.

10 Claims, 21 Drawing Sheets

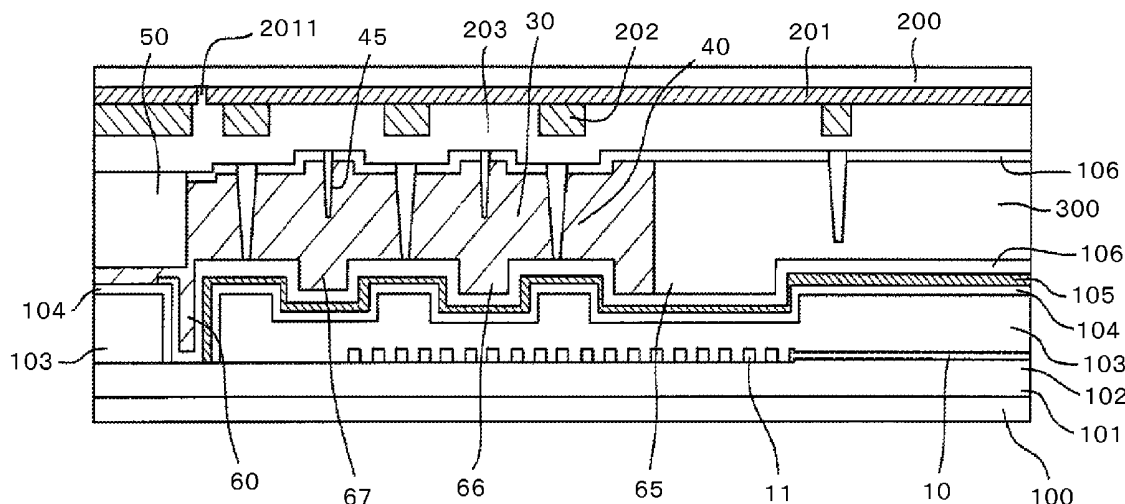


FIG. 1

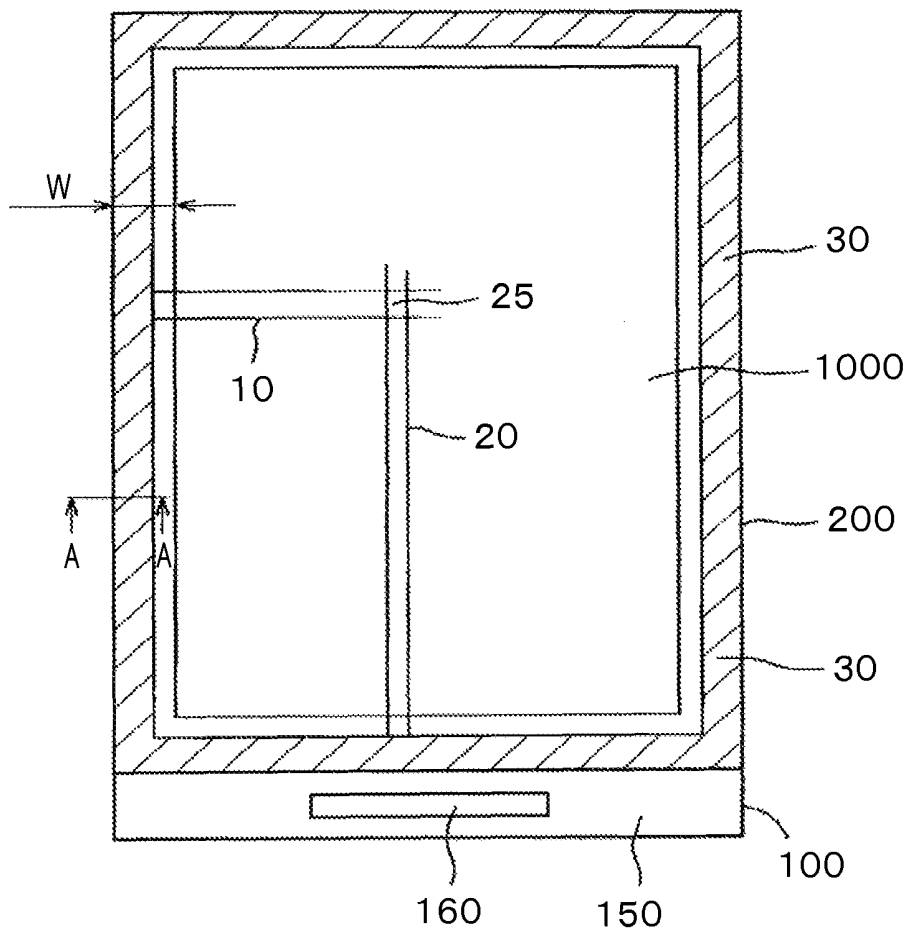


FIG. 3

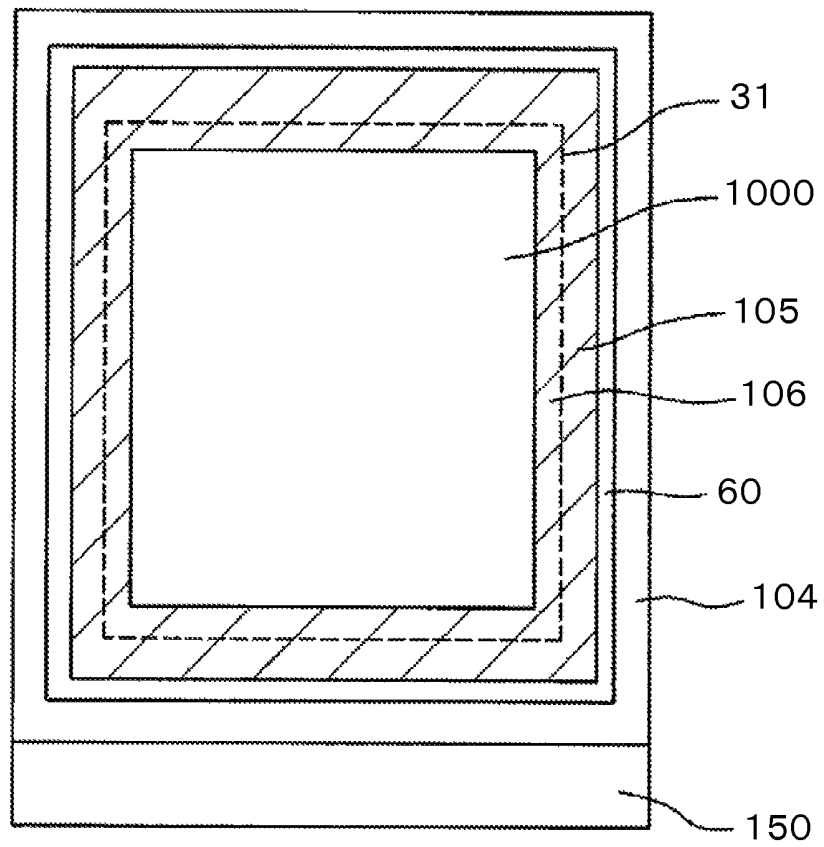


FIG. 4

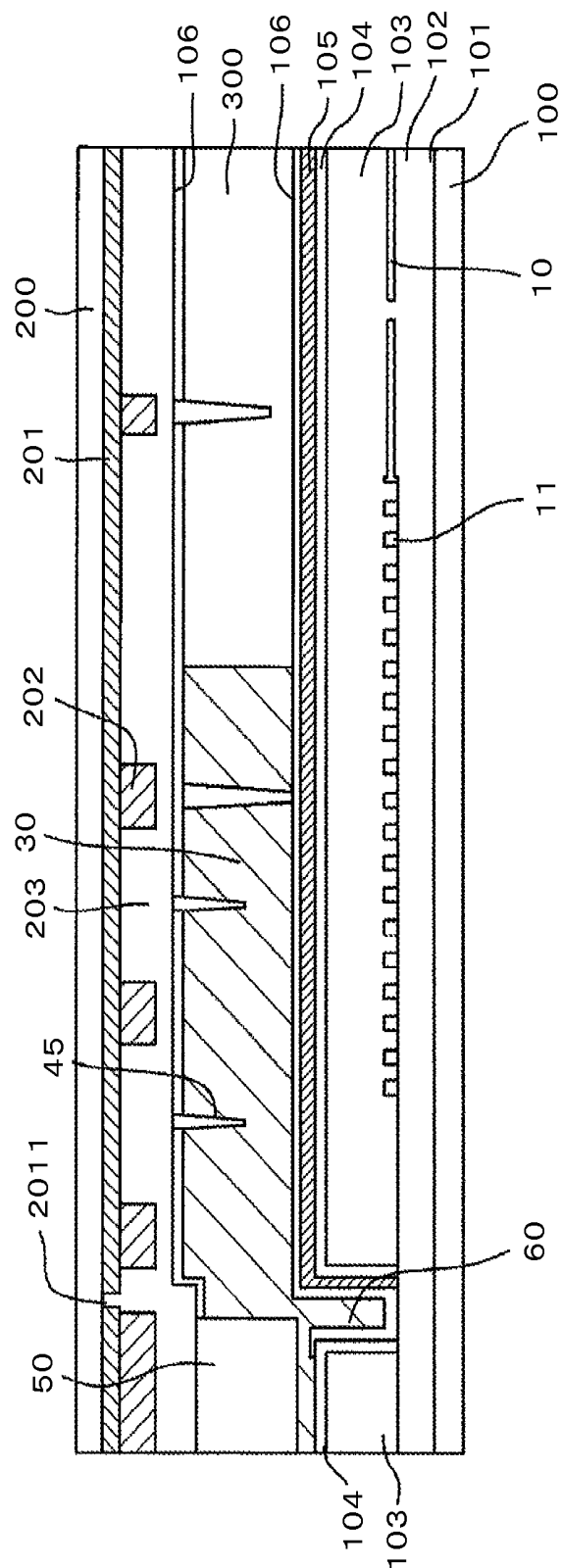


FIG. 5

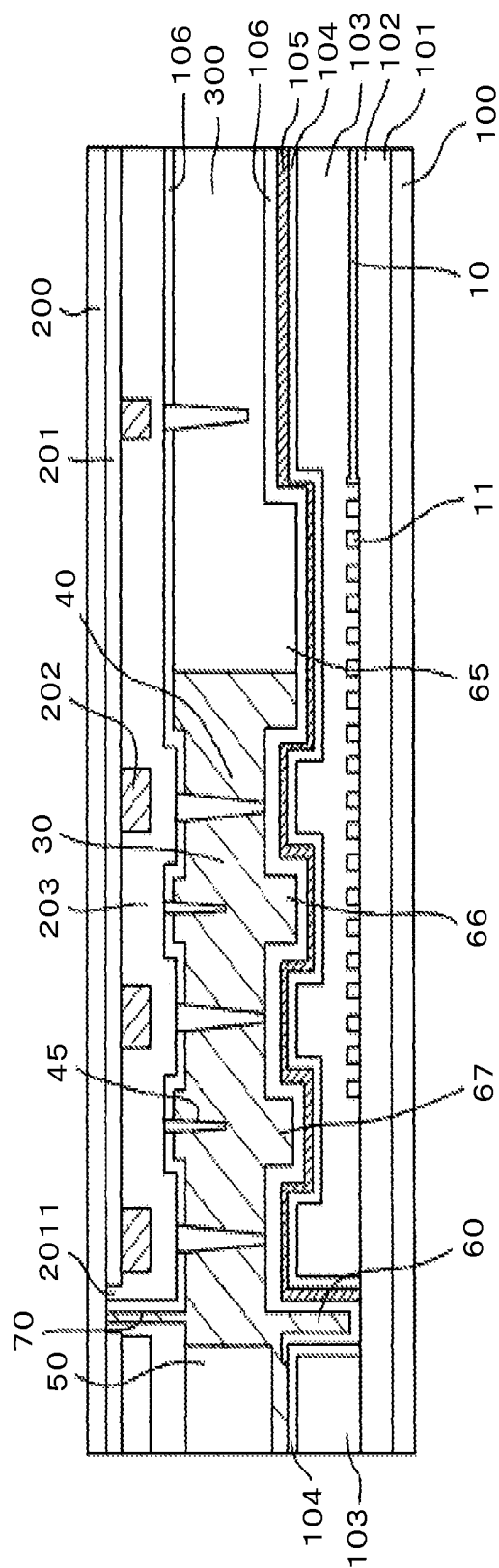


FIG. 6

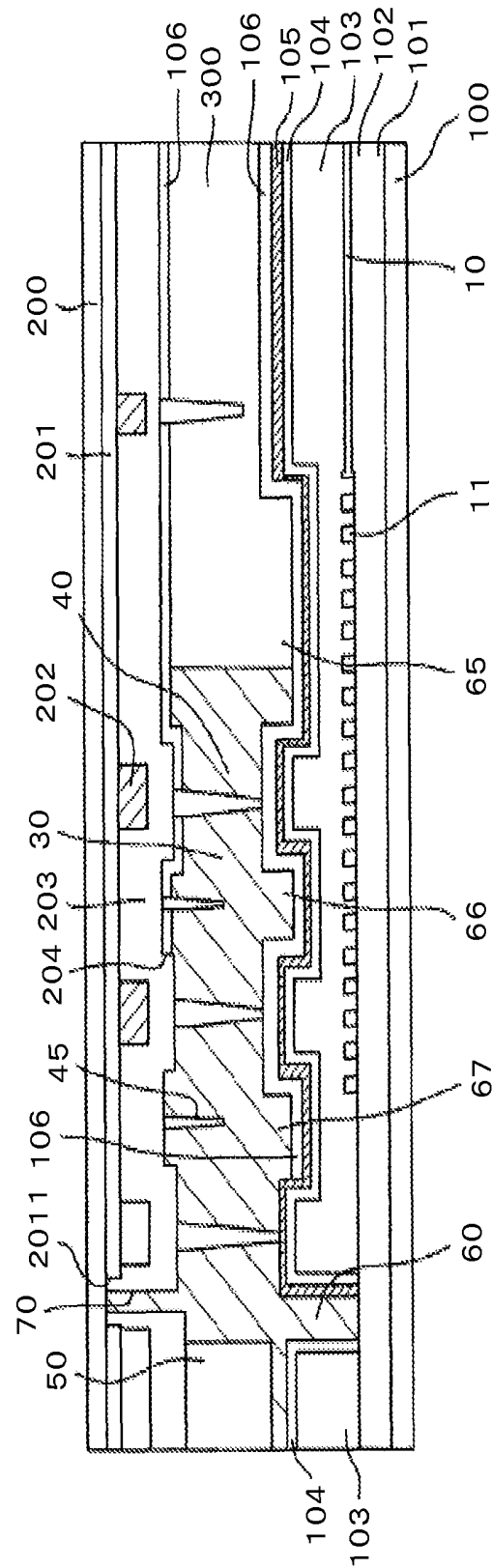


FIG. 8

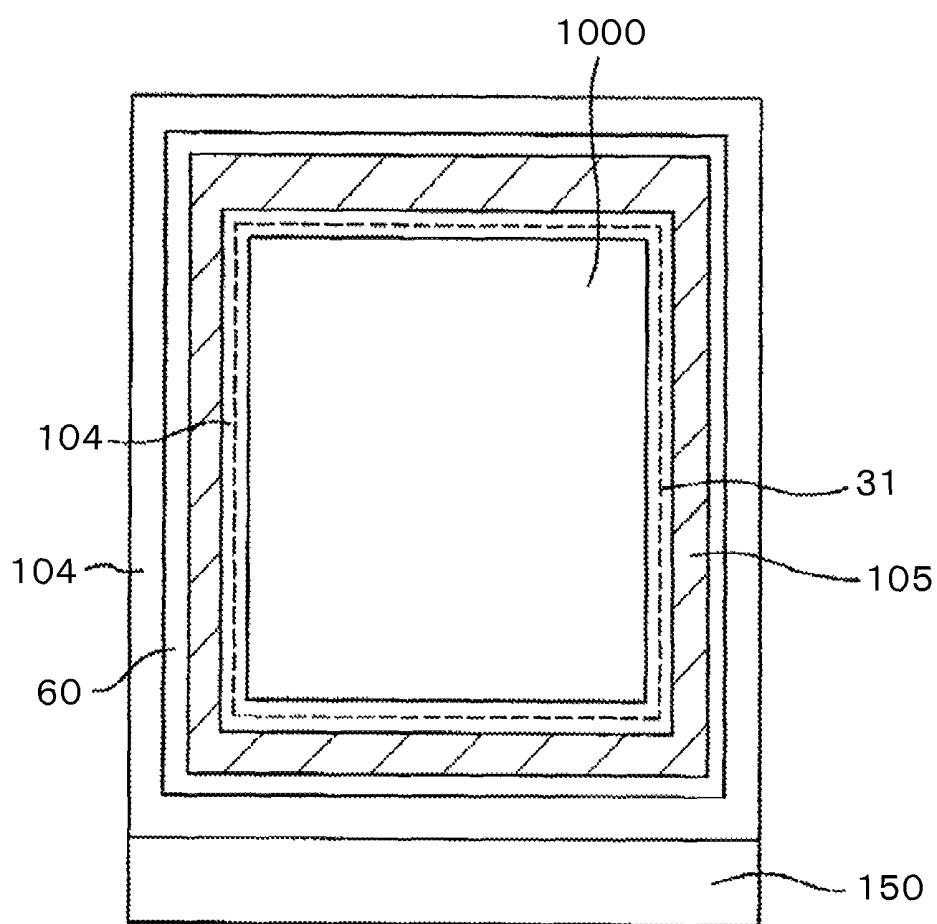


FIG. 9

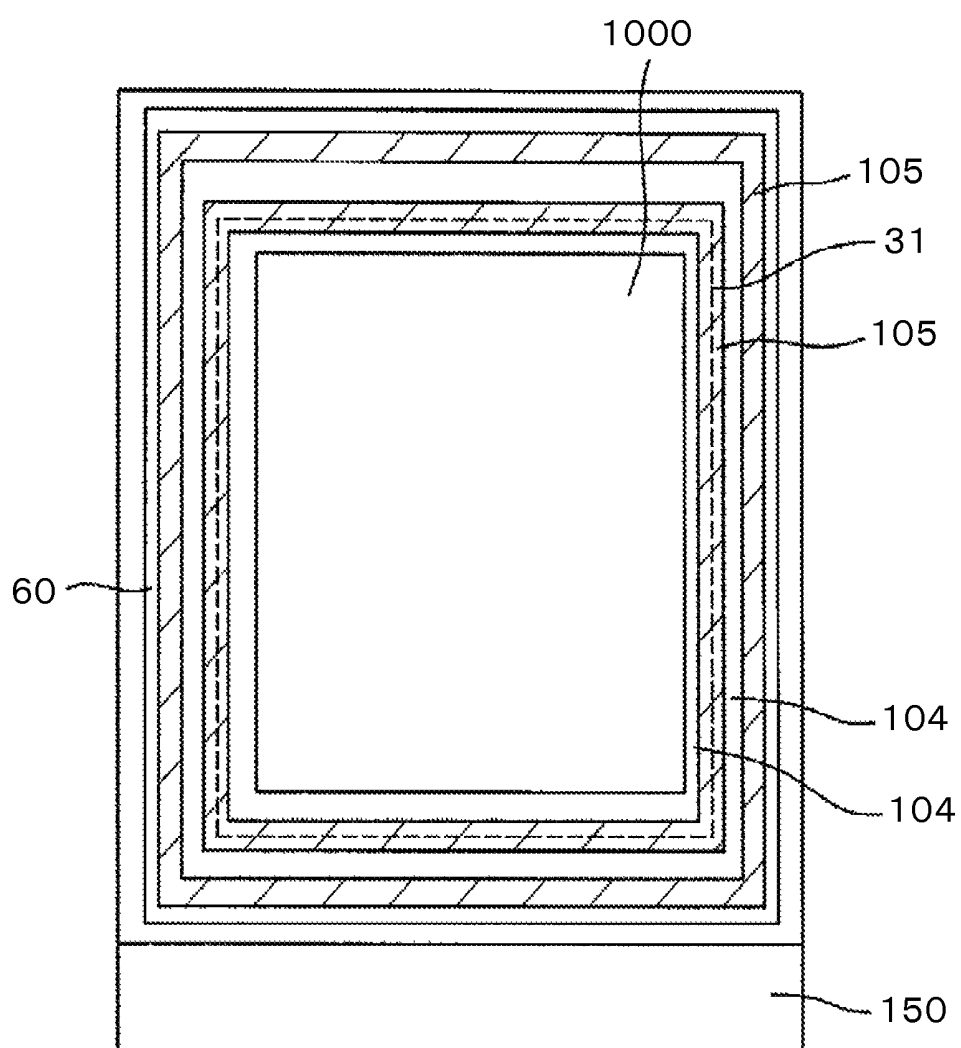


FIG. 10

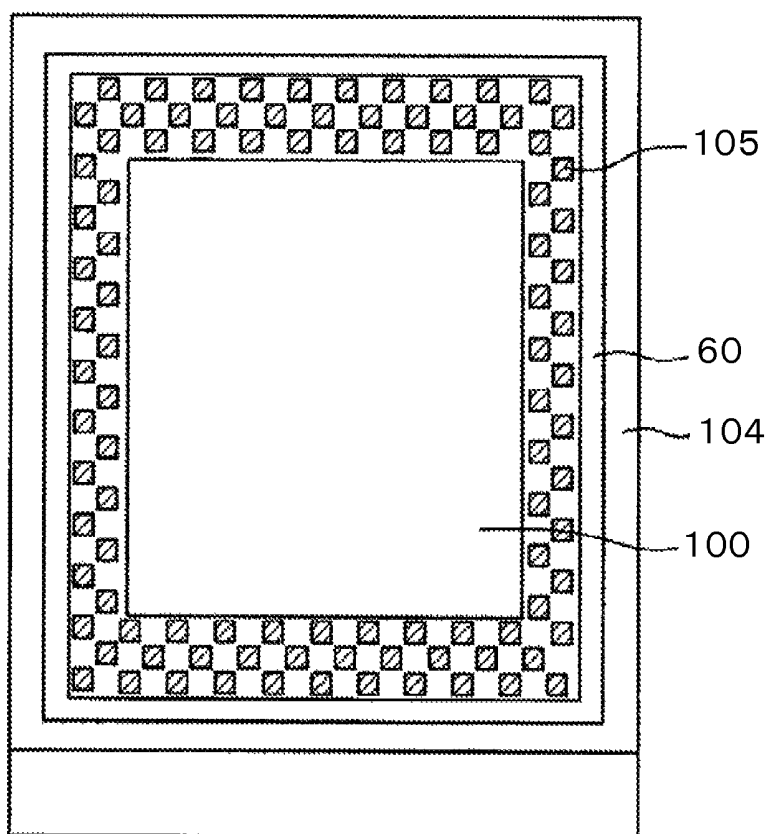


FIG. 11

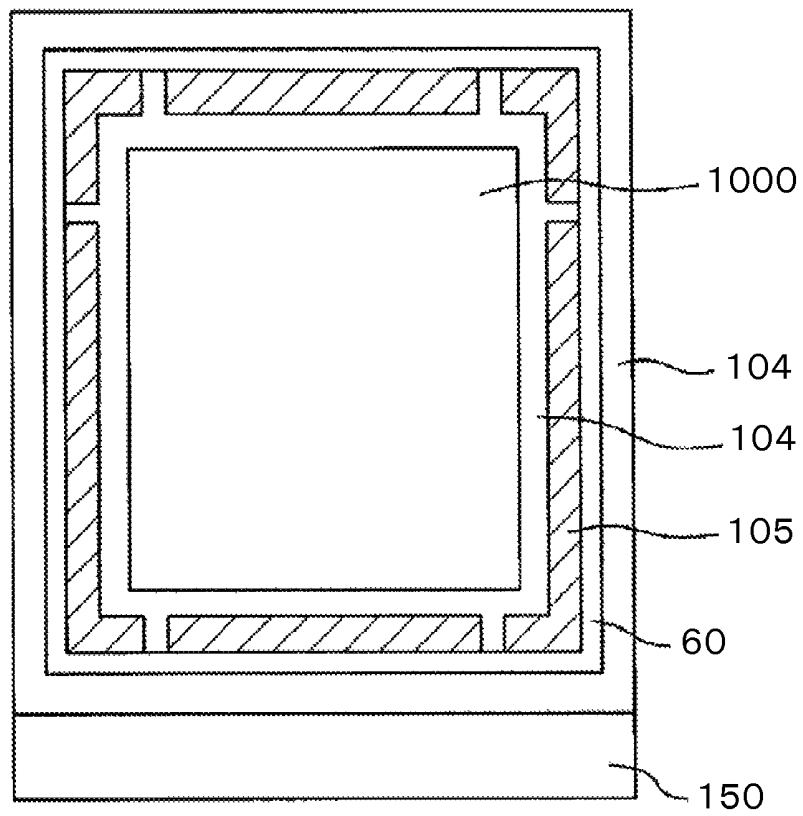


FIG. 12

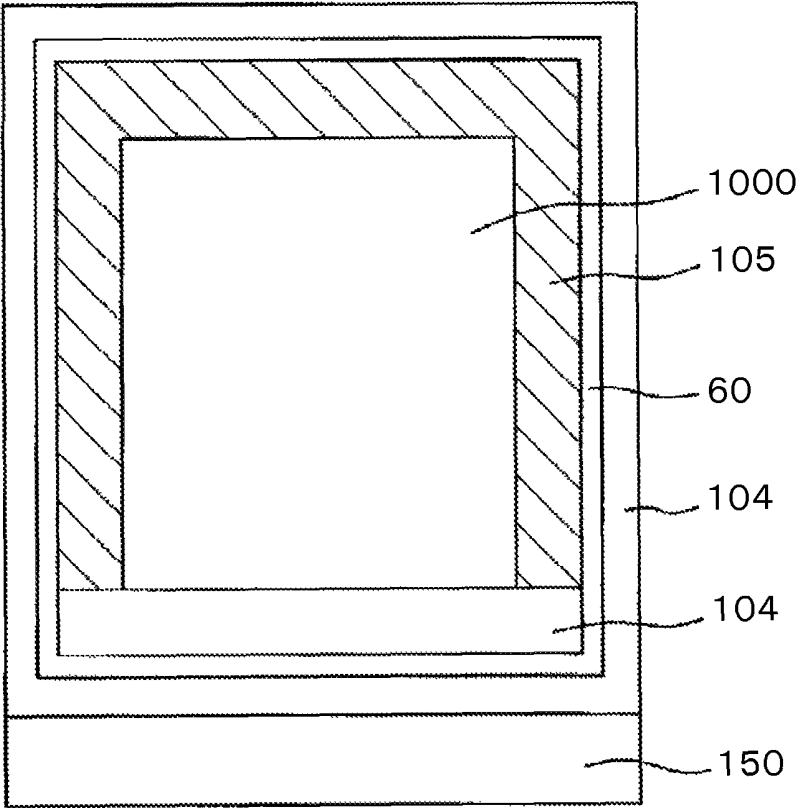


FIG. 13

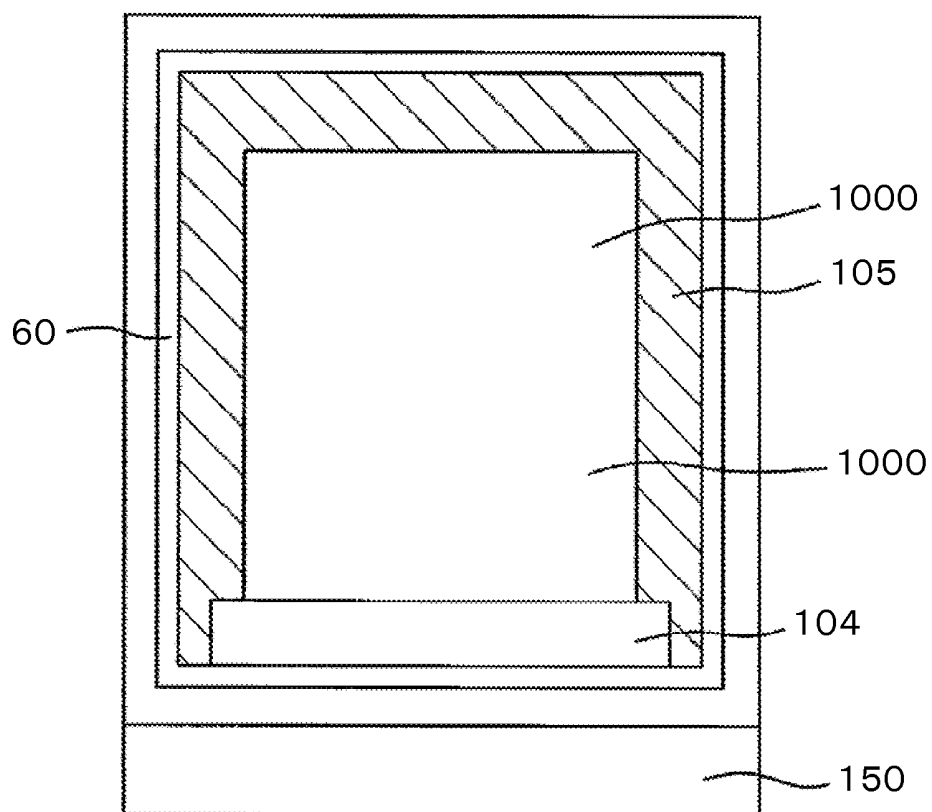


FIG. 14

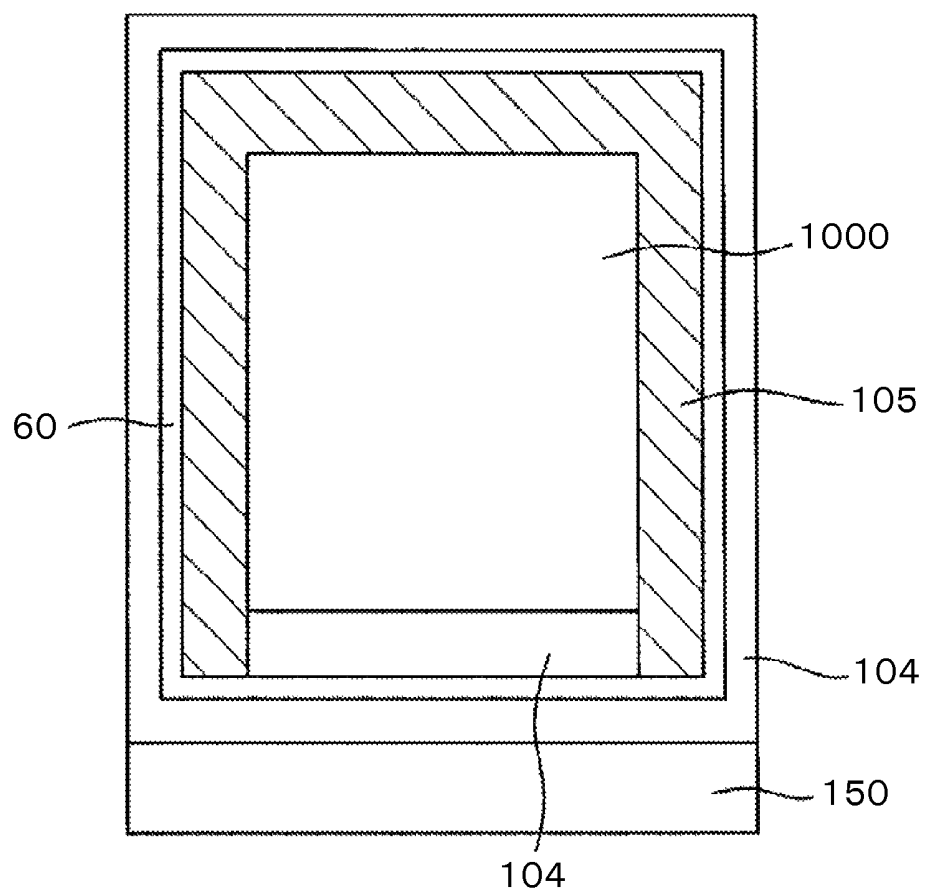


FIG. 15

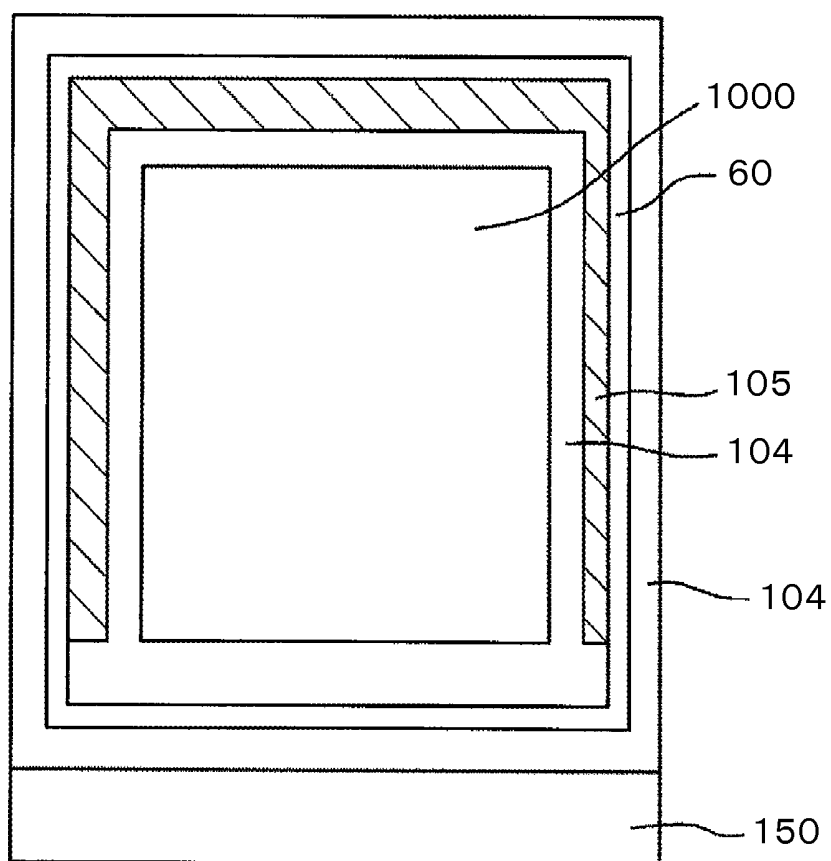


FIG. 16

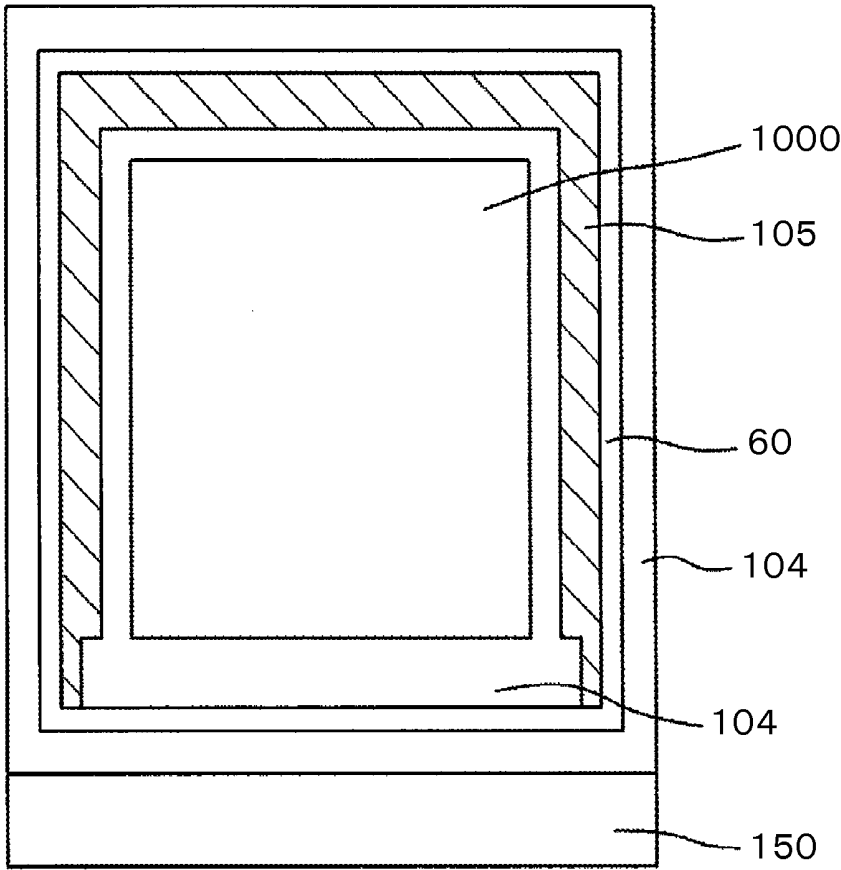


FIG. 17

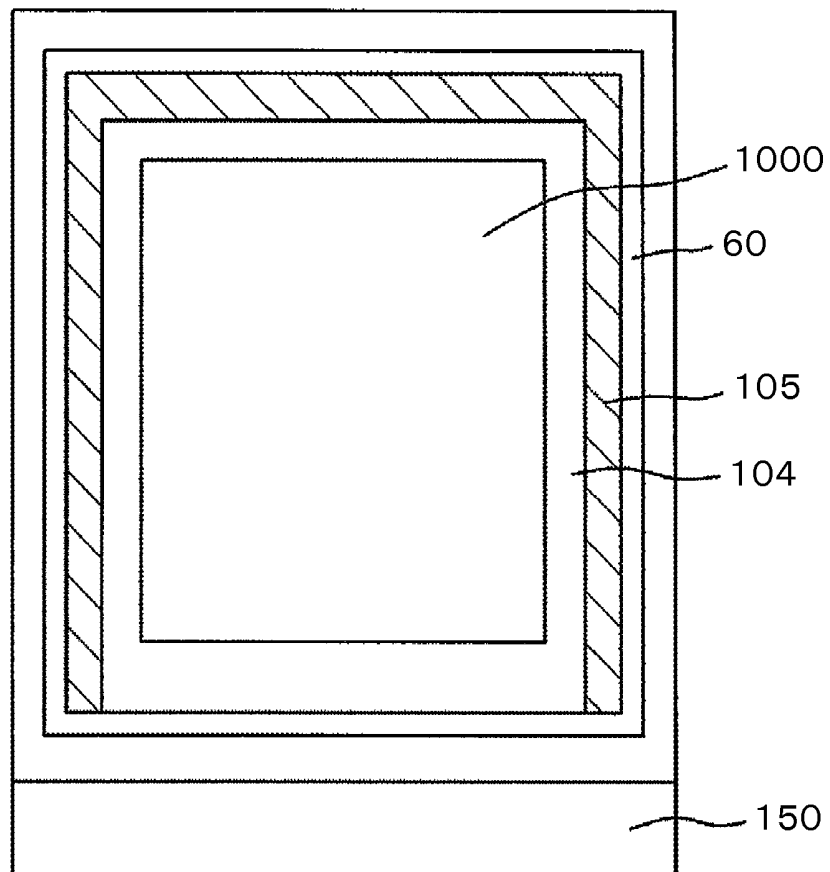


FIG. 18

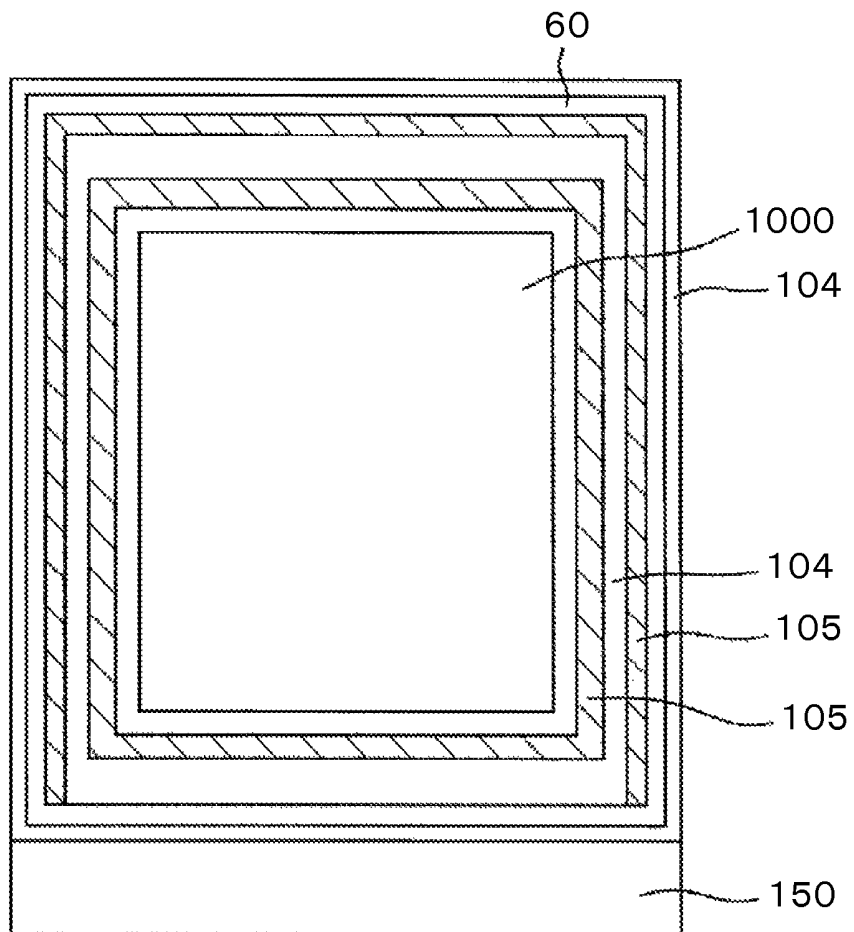


FIG. 19

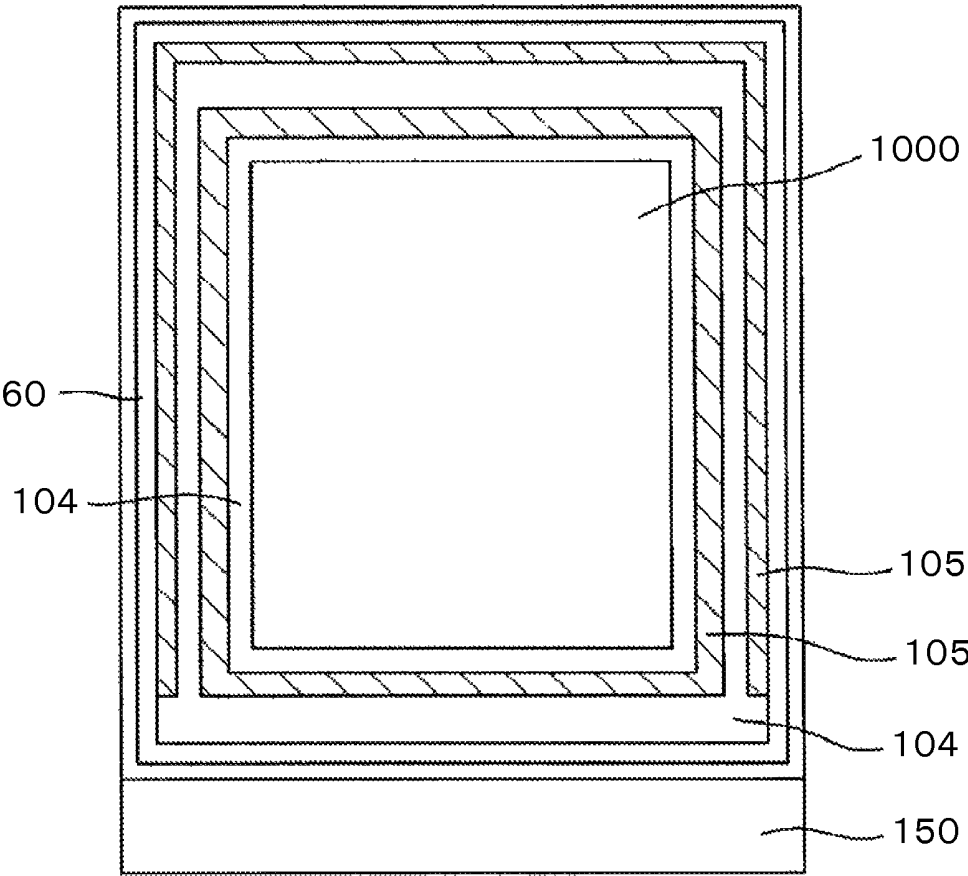
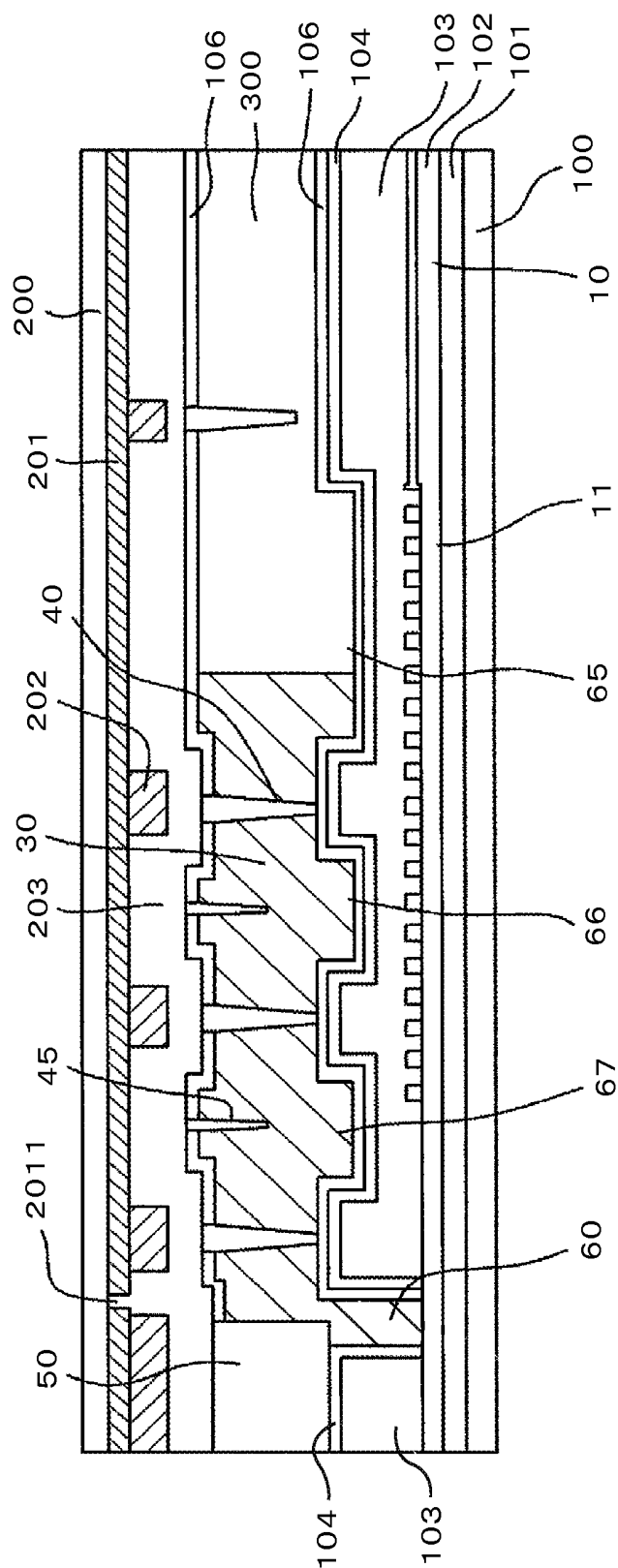


FIG. 20



LIQUID CRYSTAL DISPLAY DEVICE

CLAIM OF PRIORITY

The present application claims priority from Japanese Patent Application JP 2014-110118 filed on May 28, 2014, the content of which is hereby incorporated by reference into this application.

BACKGROUND

The present invention relates to a liquid crystal display device and more particularly, to a liquid crystal display device of a narrower frame width that can ensure reliability of a seal part.

A liquid crystal display device includes: a TFT substrate where pixels each including a pixel electrode, a thin film transistor (TFT) and the like are arranged in a matrix; a counter substrate opposed to the TFT substrate; and liquid crystal sandwiched between the TFT substrate and the counter substrate. The liquid crystal display device forms an image by controlling transmittance of light through liquid crystal molecules on a per-pixel basis.

Being flat and light in weight, the liquid crystal display device has been finding wider applications in various fields. Compact liquid crystal display devices have been widely used in cellular phones, DSCs (Digital Still Cameras) and the like. Medium- and small-sized liquid crystal display devices are faced with a strong demand for enlarging a display region while maintaining a small outside configuration. Accordingly, the liquid crystal display device is reduced in width between an edge of the display region and an edge of the device. Namely, the device is adapted to a so-called narrow frame design. The device having the narrower frame is reduced in seal width of a sealing material bonding the TFT substrate and the counter substrate together and hence, is faced with a problem of a bonding force of the seal part.

An alignment film for initial alignment of the liquid crystal molecules is formed on each of the surfaces of the TFT substrate and the counter substrate, on which surfaces the TFT substrate and the counter substrate make contact with the liquid crystal. The prior-art technique has adopted a structure where the alignment film is not formed on the seal part in order to increase the reliability in the bonding force of the seal part. In the case of the narrow frame design, however, it is difficult to exclude the alignment film from the seal part. To address the reliability in the bond of the seal part, therefore, consideration must be given to the bond strength between the sealing material and the alignment film and the bond strength between the alignment film and an underlying film thereof.

As a technique for preventing the rubbing off of the alignment film on projections resulting from wiring on the display region, Japanese Unexamined Patent Application Publication No. 2012-189856 suggests an approach to increase the bond strength of the alignment film by applying ITO (Indium Tin Oxide) on the projections. Further, Japanese Unexamined Patent Application Publication No. Hei 10-206871 discloses a structure where the wiring is formed of ITO and the ITO wiring is laid under the seal part and extended to a terminal part. Japanese Unexamined Patent Application Publication No. Hei 10-206871 does not describe a range of applying the alignment film.

SUMMARY OF THE INVENTION

As to the reliability of the seal part, attention has heretofore been paid only to the bonding force between the

sealing material and the alignment film. However, when the increase in the bonding force between the sealing material and the alignment film is achieved, then bond between the alignment film and the underlying film thereof constitutes a problem. The alignment film and the underlying film have been considered in the art to have sufficient bond strength. As the frame becomes narrower, the bonding force between the alignment film and the underlying film thereof becomes a problem.

The underlying film of the alignment film differs between a TFT-substrate side and a counter-substrate side. In most cases, an organic film called an overcoat film constitutes the underlying film on the counter-substrate side while an inorganic film made of Si or the like constitutes the underlying film on the TFT-substrate side. The alignment film is an organic film made of polyimide or the like. The bond strength between the organic film and the organic film is generally strong. However, the bond strength between the organic film and the inorganic film is comparatively weak. Therefore, the bonding force between the alignment film and the underlying film poses a problem to the TFT-substrate side.

It is an object of the present invention to increase the bond strength between the organic film and the inorganic film on the TFT-substrate side in particular and to provide a liquid crystal display device ensuring the reliability of the seal part while narrowing of the frame.

The present invention is directed to solution to the above problem and the specific means thereof are as follows.

According to a first aspect of the present invention, a liquid crystal display device includes: a TFT substrate which includes a display region and a terminal part, and has an inorganic insulating film formed on an organic passivation film and an alignment film formed over the inorganic insulating film; a counter substrate, the TFT substrate and the counter substrate bonded together by a sealing material formed at a seal part surrounding the display region; and a liquid crystal sealed inside, and

has a structure where at the seal part, a transparent conductive oxide film is formed between the inorganic insulating film and the alignment film, an edge of the transparent conductive oxide film exists inside an edge of the TFT substrate.

According to a second aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where at the seal part, the organic passivation film is formed with a groove-like through-hole surrounding the display region, and the transparent conductive oxide film is formed inside than the groove-like through-hole.

According to a third aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is made of ITO.

According to a fourth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is made of IZO.

According to a fifth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is formed on four sides surrounding the display region.

According to a sixth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is formed on the three sides except a terminal part.

According to a seventh aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is continuously formed around the display region, and the width of an overlap between the sealing material and the transparent conductive oxide film is 100 μm or more.

According to an eighth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the transparent conductive oxide film is formed in a plurality of continuous lines surrounding the display region, and the total of the widths of overlaps between the sealing material and the transparent conductive oxide film formed in the plural continuous lines is 100 μm or more.

According to a ninth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the area of an overlap between the transparent conductive oxide film and the sealing material is 20% or more of the total bond area on which the sealing material on the TFT-substrate side is bonded to the transparent conductive oxide film.

According to a tenth aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the alignment film contains a silane coupling agent.

According to an eleventh aspect of the present invention, the liquid crystal display device according to the first aspect thereof has a structure where the alignment film is subjected to optical alignment processing.

According to the present invention, the liquid crystal display device ensuring the reliability of the seal part is provided because the bonding force between the alignment film and the underlying film thereof can be ensured even in the structure where the frame is narrowed and the alignment film is applied to the seal part.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a plan view showing a liquid crystal display device according to the present invention;

FIG. 2 is a sectional view taken on the line A-A in FIG. 1 for showing a first embodiment of the present invention;

FIG. 3 is a schematic plan view of a TFT substrate corresponding to FIG. 2;

FIG. 4 is a sectional view taken on the line A-A in FIG. 1 for showing another mode of the first embodiment 1;

FIG. 5 is a sectional view taken on the line A-A in FIG. 1 for showing still another mode of the first embodiment 1;

FIG. 6 is a sectional view taken on the line A-A in FIG. 1 for showing still another mode of the first embodiment 1;

FIG. 7 is a sectional view taken on the line A-A in FIG. 1 for showing a second embodiment of the present invention;

FIG. 8 is a schematic plan view of a TFT substrate corresponding to FIG. 7;

FIG. 9 is a schematic plan view of a TFT substrate for showing an ITO forming range;

FIG. 10 is a schematic plan view of a TFT substrate according to another embodiment of the present invention for showing an ITO forming range;

FIG. 11 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 12 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 13 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 14 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 15 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 16 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 17 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 18 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range;

FIG. 19 is a schematic plan view of a TFT substrate according to still another embodiment of the present invention for showing an ITO forming range; and

FIG. 20 is a sectional view taken on the line A-A in FIG. 1.

FIG. 21 is a sectional view taken on the line A-A in FIG. 1 according to another mode of the present invention.

DETAILED DESCRIPTION

Before describing specific embodiments of the present invention, a brief description is made on a structure of a liquid crystal display device. FIG. 20 is a sectional view showing an example of a seal part of the liquid crystal display device. Referring to FIG. 20, liquid crystal 300 is sandwiched between a TFT substrate 100 and a counter substrate 200. An alignment film 106 is formed on each of the surfaces of the TFT substrate 100 and the counter substrate 200, on which surfaces the TFT substrate 100 and the counter substrate 200 make contact with the liquid crystal 300. At a narrow frame, the alignment film 106 is extended to a seal part, where the TFT substrate 100 and the counter substrate 200 are bonded together by a sealing material 30. The prior-art techniques have addressed the bond strength between the sealing material 30 and the alignment film 106. As the frame becomes narrower, however, bond strength between the alignment film 106 and an underlying film thereof is considered as a problem. On the TFT-substrate 100 side, in particular, the problem is the bonding force between the alignment film 106 and an inorganic insulating film 104 which is formed of SiN or the like as the underlying film of the alignment film.

On the other hand, a so-called viewing angle means much to the liquid crystal display. The IPS (In Plane Switching) system has excellent characteristics in the viewing angle. Alignment processing for the alignment film 106 includes a conventional rubbing method and a so-called optical alignment method which produces uniaxial anisotropy in the alignment film by irradiating the alignment film with polarized ultraviolet rays. In the IPS system, the optical alignment method is more suitable because the method negates the need for inducing liquid-crystal pretilt angle on the alignment film 106.

The alignment film 106 is irradiated with the ultraviolet rays in the optical alignment processing, which involves a fear that the ultraviolet rays may reach an interface between the alignment film 106 and the SiN film 104 as the underlying film thereof, inducing a decrease in the bonding force.

Therefore, the problem of bonding force between the alignment film **106** and the underlying film **104** can be more critical in the IPS system.

The present invention to be described hereinbelow is directed to solution to the above problem. The contents of the present invention will be specifically described as below with reference to embodiments thereof.

First Embodiment

FIG. 1 is a plan view showing a liquid crystal display device to which the present invention is applied. Referring to FIG. 1, the TFT substrate **100** and the counter substrate **200** are bonded together by the sealing material **30** while the liquid crystal is sandwiched between the TFT substrate **100** and the counter substrate **200**. The TFT substrate **100** is formed in a larger size than the counter substrate **200**. A portion of the TFT substrate **100** that extends as a single layer defines a terminal part **150**. The terminal part **150** is formed with an IC driver **160** for driving a liquid crystal display panel, terminals for connection of a flexible wiring board for supplying electric power, image signals, scan signals and the like to the liquid crystal display panel, and the like.

Referring to FIG. 1, a display region **1000** includes scanning lines **10** extended horizontally and arranged vertically, and further includes image signal lines **20** extended vertically and arranged horizontally. An area enclosed by the scanning line **10** and the image signal line **20** defines a pixel **25**. At the narrow frame, a distance w between an edge of the display region **1000** and an edge of the liquid crystal display device is reduced to the order of 1 mm. In this case, the device can allow for no more than 0.5 mm of bond width for the sealing material **30**, which makes the bond strength at the seal part a crucial matter.

FIG. 2 is a detailed sectional view of the seal part, corresponding to a cross section taken on the line A-A in FIG. 1. Referring to FIG. 2, a first insulating film **101** is formed on the TFT substrate **100** made of glass. The first insulating film **101** may sometimes be an undercoat film formed for preventing a semiconductor layer of the TFT from being contaminated with impurities from the glass. A second insulating film **102** is formed on the first insulating film **101**. The second insulating film **102** may sometimes be a gate insulating film of the TFT. On the second insulating film **102**, the scanning lines **10** and scanning-line lead lines **11** are formed. The rectangular scanning-line lead line **11** represents a cross section of the scanning-line lead line **11** extended from an upper side as seen in the drawing of FIG. 1.

An organic passivation film **103** is overlaid on the scanning lines **10** and the scanning-line lead lines **11**. The passivation film **103** is formed thick or 2 to 3 μm in thickness and also serves as a flattening film. The passivation film **103** is formed of a photosensitive resin, negating the need for photoresist when patterned.

An interlayer insulating film **104** made of SiN is overlaid on the organic passivation film **103**. In the display region of the IPS liquid crystal display device, this interlayer insulating film **104** is an insulating film between a lower layer electrode formed in a flat solid layer and an upper layer electrode including slits. The lower layer electrode may be a common electrode while the upper layer electrode may be a pixel electrode, and vice versa. Both the lower layer electrode and the upper layer electrode are formed of a transparent conductive oxide film **105** represented by ITO (Indium Tin Oxide). While the following description is made

on the assumption that the transparent conductive oxide film **105** is made of ITO, the transparent conductive oxide film **105** may sometimes be made of IZO (Indium Zinc Oxide).

Referring to FIG. 2, the ITO **105** is formed on the interlayer insulating film **104**, which constitutes a feature of the present invention. This ITO **105** is at least insulated from the ITO of the pixel electrodes in the display region **1000**. However, the ITO **105** is formed in conjunction with the formation of the upper layer electrode in the display region.

The alignment film **106** is overlaid on the ITO **105**. The bonding force between the alignment film **106** and the ITO **105** is so strong that the bond strength between the alignment film **106** and the ITO **105** can be ensured despite the narrow seal width. Although the bonding force between the alignment film **106** and the ITO **105** also means much to other parts, the bonding force particularly constitutes a crucial problem to the seal part, where stress occurs between the sealing material **30** and the alignment film with the ITO.

In a case where the alignment film **106** includes a silane coupling agent, the bonding force between the alignment film **106** and the ITO **105** can be further increased. This is because an OH-group of the alignment film **106** is strongly bonded to an OH-group of the ITO **105**. Incidentally, the ITO **105** is also strongly bonded to the interlayer insulating film **104** as the underlying film thereof which is made of SiN. Since the ITO **105** does not extend so far as an edge of the TFT substrate **100**, there is no fear of invasion of moisture through an interface between the ITO **105** and other layers in contact therewith.

The alignment film **106** is formed by applying an alignment film material as a starting liquid by flexography, ink-jet printing or the like. The organic passivation film **103** is formed with recesses **65**, **66**, **67** as a stopper for preventing the alignment material from spreading so far as an outside edge of the seal part. Further, a groove-like through-hole **60** formed on an even outer side of the recesses also serves as the stopper for the alignment film material. FIG. 2 shows the alignment film material spreading beyond the three recesses **65**, **66**, **67** and ending at the groove-like through-hole **60** as the final stopper.

Referring to FIG. 2, a black matrix **201** is formed on the counter-substrate **200** side. The black matrix **201** in FIG. 2 is disposed for preventing light leakage from the seal part **30**. The black matrix **201** is formed of a resin and hence, the black matrix is formed with a black matrix groove **2011** for blocking moisture permeation through the resin. On the black matrix **201**, a color filter **202** is formed in a strip pattern extended in a direction perpendicular to the drawing surface. The color filter **202** is formed in correspondence to a column-like spacer **40** formed on an overcoat film **203**.

The overcoat film **203** is formed on the color filter **202**. The overcoat film **203** is formed with protrusions at places corresponding to the color filter **202**. This protrusion has a function to prevent the alignment film material being applied from spreading toward the outside of the substrate. A first column-like spacer **40** is formed at the protrusion of the overcoat film **203**. The first column-like spacer **40** has a function to define a distance between the counter substrate **200** and the TFT substrate **100** at the seal part. Between the first column-like spacer **40** and the first column-like spacer **40**, a second column-like spacer **45** which has a smaller height than the first column-like spacer **40** is formed. The second column-like spacer **45** has a function to prevent the distance between the TFT substrate **100** and the counter substrate **200** from being excessively reduced when an external pressure is applied to the counter substrate **200**.

The alignment film **106** is overlaid on the overcoat film **203**. A wall-like spacer **50** is formed at an end of the seal part. The wall-like spacer **50** is placed on a boundary between adjoining liquid crystal display panels on a mother substrate where a plurality of liquid crystal display panels are formed. Scribing is performed along the center of the wall-like spacer **50**, followed by separating the individual liquid crystal display panels by breaking the mother substrate. The reason for locating the wall-like spacer at this portion is that the mother substrate cannot be broken despite the scribing performed on the spacer if the sealing material **30** exists at this portion. Referring to FIG. 2, the sealing material **30** is present in a slight gap between the wall-like spacer **50** and the TFT-substrate **100** side. However, this sealing material does not affect the breaking operation significantly so long as the thickness of the sealing material in this gap is 1 μm or less. In some cases, the sealing material **30** having a thickness of 1 μm or less may contribute to bonding between the counter substrate **200** and the TFT substrate **100**.

Referring to FIG. 2, the alignment film **106** formed on the counter-substrate **200** side extends beyond the protrusions formed on the overcoat film **203** and ends at the wall-like spacer **50**. On the counter-substrate **200** side, the alignment film **106** is formed on the overcoat film **203**. Both the overcoat film **203** and the alignment film **106** are formed of organic materials. The bonding force between the organic materials is so strong that the bonding force between the alignment film **106** and the overcoat film **203** does not matter much.

At the seal part, the TFT substrate **100** and the counter substrate **200** are bonded together by the sealing material **30**. Although the sealing material **30** is bonded to the alignment films **106** as seen in FIG. 2, the bond between the sealing material **30** and the alignment films **106** can be practically maintained. In FIG. 2, the liquid crystal **300** is filled in space inside the sealing material **30**.

FIG. 3 is a plan view of the TFT substrate **100** shown in FIG. 1 and FIG. 2. FIG. 3 is a schematic diagram showing relationships among the seal part, the display region **1000**, the interlayer insulating film **104**, the groove-like through-hole **60** and the ITO **105**. Referring to FIG. 3, an area outside a dotted line **31** defines the seal part where the sealing material is formed. Around the display region, the ITO **105** is formed and its outside is surrounded by the groove-like through-hole **60**, external to which is the interlayer insulating film **104** covering the organic passivation film.

The alignment film **106** covers the display region **1000** and an area between the display region **1000** and the groove-like through-hole **60**. At the seal part, the alignment film **106** is formed on the ITO **105**. The bonding forces between the ITO **105** and the alignment film **106** and between the ITO **105** and the interlayer insulating film **104** made of SiN are strong enough. Therefore, the alignment film **106** at the seal part shown in FIG. 3 has high reliability in bonding. Further, the ITO **105** does not extend so far as the edge of the TFT substrate **100** and hence, there is no fear of moisture invading from the edge of the TFT substrate **100** through the interface of the ITO **105**.

FIG. 4 is a sectional view showing another mode of this embodiment. FIG. 4 differs from FIG. 2 in that the organic passivation film **103** of the TFT substrate **100** is not formed with the recesses. As shown in FIG. 4, the alignment film **106** ends at the groove-like through-hole **60** of the organic passivation film **103**. As seen in FIG. 4 as well, the ITO **105** is formed between the interlayer insulating film **104** and the alignment film **106** and hence, the bond performance of the

alignment film **106** can be ensured. Further, the ITO **105** does not extend so far as the edge of the TFT substrate **100** and hence, there is no fear of moisture invading from the edge of the TFT substrate **100** through the interface of the ITO **105**.

FIG. 5 is a sectional view showing still another mode of this embodiment. FIG. 5 differs from FIG. 2 in that the overcoat film **203** on the counter-substrate **200** side is formed with a groove **70**. This groove **70** is formed in a configuration to surround the display region **1000**. The overcoat-film groove **70** has the same function as that of the groove-like through-hole **60** formed in the organic passivation film **103** on the TFT substrate **100**. Namely, this groove blocks the external moisture invading through the overcoat film **203**.

As seen in FIG. 5, the alignment film **106** ends at the overcoat-film groove **70**. Further, the sealing material **30** is also filled in the overcoat-film groove **70**. The other components are the same as those of the FIG. 2 and the effects thereof are also the same as those of FIG. 2.

FIG. 6 is a sectional view showing still another mode of this embodiment. FIG. 6 differs from FIG. 5 in that the alignment films **106** are not extended to the vicinity of the edge of the sealing material **30** but ends at some point short of the edge of the sealing material. In a case where the bond between the sealing material **30** and the alignment film **106** is somewhat weak, the mode shown in FIG. 6 is better adapted to increase the reliability of the seal part.

Referring to FIG. 6, the alignment film **106** on the TFT-substrate **100** side ends at the third recess **67** while the alignment film on the counter-substrate **200** side ends at the second protrusion from the display region. On the TFT-substrate **100** side, the sealing material **30** is bonded to the alignment film **106**, the ITO **105**, and the interlayer insulating film **104**. On the counter-substrate **200** side, the sealing material **30** is bonded to the alignment film **106**, and the overcoat film **203**. The bond strength between the sealing material **30** and the ITO **105**, the bond strength between the sealing material and the interlayer insulating film **104**, and the bond strength between the sealing material **30** and the overcoat film **203** are greater than the bond strength between the sealing material **30** and the alignment film **106**.

As described above, this embodiment is adapted to prevent the separation of the alignment film **106** at the seal part on the TFT-substrate **100** side and hence, can increase the reliability of the seal part.

Second Embodiment

FIG. 7 is a sectional view showing as second embodiment of the present invention. FIG. 7 is a sectional view also corresponding to the sectional view taken on the line A-A in FIG. 1. FIG. 7 differs from FIG. 2 of the first embodiment in that the ITO **105** formed on the TFT-substrate **100** side does not extend so far as an inside edge of the sealing material **30**. In this case, as well, the ITO **105** exists between the alignment film **106** and the interlayer insulating film **104** at a main portion of the sealing material **30** and hence, the separation of the alignment film **106** at the seal part **30** can be prevented. The other components in FIG. 7 are the same as those of FIG. 2.

FIG. 8 is a plan view of the TFT substrate **100** corresponding to the structure of FIG. 7, or a schematic diagram showing relationships among the display region **1000**, the range of the ITO **105**, the interlayer insulating film **104**, the groove-like through-hole **60** and the like. Referring to FIG. 8, an area outside the dotted line **31** defines the seal part

where the sealing material 30 is formed. The ITO 105 extends within a range of the width of the sealing material 30 but not so far as the inside edge of the sealing material 30.

The range of applying the alignment film 106 is the whole area that is inside the groove-like through-hole 60 formed in the organic passivation film 103 and that includes the display region 1000. This embodiment is also adapted to prevent the separation of the alignment film because at a major part with respect of the seal width, the ITO 105 is disposed between the alignment film 106 and the interlayer insulating film 104. Similarly to the first embodiment, therefore, this embodiment is also adapted to increase the reliability of the seal part.

FIG. 21 is another sectional view corresponding to the sectional view taken on the line A-A in FIG. 1. FIG. 21 differs from FIG. 7 in that the alignment film 106 is formed until the edge of the TFT substrate 100 and the counter substrate 200. In FIG. 21, the ITO 105 exists between the alignment film 106 and the interlayer insulating film 104 at a main portion of the sealing material 30 and hence, the separation of the alignment film 106 at the seal part 30 can be prevented, even the alignment film 106 is formed until the edge of the TFT substrate 100. Manufacturing becomes much easier if imitation of alignment film 106 is not necessary.

In FIG. 21, the alignment film 106 on the counter substrate 200 is formed until the edge of the counter substrate 200, however, the alignment film 106 on the counter substrate 200 can be stopped before it extends to the edge of the counter substrate 200 in a manner as depicted in FIGS. 2, 4-7.

In FIG. 21, ITO 105 doesn't extend so far as an inside edge of the sealing material 30, however, ITO 105 can extend beyond the inside edge of the sealing material 30 in a manner as depicted in FIG. 2, 4-6.

Third Embodiment

FIG. 9 to FIG. 19 each show an example of the range of forming the ITO 105 on the TFT substrate 100 according to the present invention. In each of the drawings, the alignment film 106 is formed on the whole area that is inside the groove-like through-hole 60 formed in the organic passivation film 103 and that includes the display region 1000. However, the alignment film 106 may also be formed on the whole area of the TFT substrate 100, the area including the seal part. Further, in the range of an overlap between the alignment film 106 and the sealing material 30, an outside edge of the alignment film 106 may sometimes be located inside the groove-like through-hole 60 of the organic passivation film 103. In all the examples, however, the ITO 105 is formed in the range that is inside the groove-like through-hole 60 formed in the organic passivation film 103. That is, the ITO 105 is formed inside the outside edge of the sealing material 30.

FIG. 9 shows an example where the range of applying the ITO 105 is divided into two line portions and the inside edge 31 of the sealing material 30 is formed on the inner ITO 105. In this case, a part of the sealing material 30 is bonded to the interlayer insulating film 104 but the greater part of the sealing material 30 overlaps with the ITO 105. Therefore, the separation of the alignment film at the seal part can be prevented and the bond strength of the seal part can be ensured.

It is desirable that the range where the ITO 105 overlaps with the sealing material 30 is 100 μm or more in terms of

width. In the case where the range of the overlap between the ITO 105 and the sealing material 30 is divided into two line portions as shown in FIG. 9, the total of the two line portions of the ITO 105 may be defined to be 100 μm or more. The same also applies to a case where the ITO includes three or more portions.

FIG. 10 shows an example where the ITO 105 is formed in a plurality of islands rather than in a continuous configuration. Referring to FIG. 10, while the sealing material 30 may have the inside edge located at any place, the range of the overlap between the sealing material 30 and the ITO 105 may preferably be defined to be 20% or more of the bond area of the sealing material 30.

FIG. 11 shows an example where the ITO 105 is formed in a frame-like configuration, each side of which includes a gap extended toward the outside of the TFT substrate. The ITO may sometimes be laid out as shown in FIG. 11 due to wiring reasons or the like. In this case, as well, the area of the overlap between the ITO 105 and the sealing material 30 may be defined to be 20% or more of the bond area of the sealing material 30.

FIG. 12 shows an example where the ITO 105 has three sides configured the same way as in FIG. 3 except for one side abutting on the terminal part 150, or the ITO 105 is not formed on the side abutting on terminal part 150. The lead lines of the image signal lines 20, scanning lines 10 and the like are concentrated on the terminal-part 150 side, where it may sometimes be difficult to form the ITO 105 over the interlayer insulating film 104 due to layout reasons. On the other hand, the seal part on the terminal-part 150 side permits the frame to be formed wider than the seal parts on the other three sides. With the increased seal width and production tolerance taken into account, an overlap between the seal part and the alignment film can be omitted. In some cases, the seal part can ensure the bonding force if the ITO 105 is not provided on the terminal-part 150 side. FIG. 13 and FIG. 14 each show an exemplary modification of the range of removing the ITO 105 from the terminal-part 150 side. The modifications have the same effect as that described with reference to FIG. 12.

FIG. 15 shows an example where the ITO 105 has the three sides configured the same way as in FIG. 8 except for the one side abutting on the terminal part 150, or the ITO 105 is not formed on the side abutting on the terminal part 150. FIG. 16 and FIG. 17 each show an exemplary modification of the range of removing the ITO 105 from the terminal-part 150 side. The modifications have the same effect as that described with reference to FIG. 12.

FIG. 18 shows an example where the ITO 105 is formed in two lines on the three sides around the display region 1000 except for the terminal-part 150 side, similarly to the layout shown in FIG. 9, and on the terminal-part 150 side, only the inner ITO line 105 is overlapped with the sealing material 30. In FIG. 18, the scanning lines 10 and the outer ITO line 105 are not extended in parallel with the terminal-part 150 side but extended to the edges of the interlayer insulating film 104. FIG. 19 shows an exemplary modification where only the inner ITO line 105 is overlapped with the sealing material 30 on the terminal-part 150 side while the outer ITO line 105 is not extended to the edges of the interlayer insulating film 104 on the terminal-part 150 side.

While the various examples of the ranges of forming the ITO 105 have been described above, what is common to the examples is that in the case of the ITO 105 formed around the display region 100, the width of the overlap between the ITO 105 and the sealing material 30 is 100 μm or more and that in the case of the ITO 105 not formed in the continuous

11

configuration, the area of the overlaps between the ITO **105** and the sealing material **30** is 20% or more of the bond area of the sealing material **30**. It is noted here that the term “the bond area of the sealing material **30**” means the area on which the sealing material **30** on the TFT-substrate **100** side is bonded to the ITO. In the case where a plurality of annular ITOs **105** are formed and the plural ITOs **105** overlap with the sealing material **30**, the common feature is that the total of the widths of overlaps between the plural ITOs **105** and the sealing material **30** is 100 μm or more.

According to the above description, the ITO **105** as the transparent conductive oxide film **105** is formed between the interlayer insulating film **104** and the alignment film **106**. The ITO **105** can be formed in conjunction with the formation of the pixel electrodes or common electrodes made of ITO on the display region. In the case where the pixel electrodes or the common electrodes are made of IZO, however, the transparent conductive oxide film **105** formed between the interlayer insulating film **104** and the alignment film **106** may be made of IZO.

According to the present invention as described above, the separation of the alignment film at the seal part can be prevented and hence, the liquid crystal display device having the narrower frame can ensure the reliability of the seal part. When the optical alignment processing is performed on the alignment film of the IPS system, the bonding force between the alignment film and the underlying film thereof is decreased. Therefore, the present invention is particularly effective in the IPS system using the optical alignment.

What is claimed is:

1. A liquid crystal display device comprising:

a TFT substrate which includes a display region and a terminal part, and has an organic passivation film, an inorganic insulating film formed on the organic passivation film and an alignment film formed over the inorganic insulating film;

a counter substrate, the TFT substrate and the counter substrate bonded together by a sealing material formed at a seal part surrounding the display region; and

a liquid crystal sealed inside,

12

wherein at the seal part, a transparent conductive oxide film is formed between the inorganic insulating film and the alignment film,

an edge of the transparent conductive oxide film exists inside an edge of the TFT substrate,

wherein the transparent conductive oxide film is formed on three sides except the terminal part.

2. The liquid crystal display device according to claim 1, wherein at the seal part, the organic passivation film is formed with a groove-like through-hole surrounding the display region, and the transparent conductive oxide film is formed inside than the groove-like through-hole.

3. The liquid crystal display device according to claim 1, wherein the transparent conductive oxide film is made of ITO.

4. The liquid crystal display device according to claim 1, wherein the transparent conductive oxide film is made of IZO.

5. The liquid crystal display device according to claim 1, wherein the transparent conductive oxide film is formed on four sides surrounding the display region.

6. The liquid crystal display device according to claim 1, wherein the transparent conductive oxide film is continuously formed around the display region, and the width of an overlap between the sealing material and the transparent conductive oxide film is 100 μm or more.

7. The liquid crystal display device according to claim 1, wherein the transparent conductive oxide film is formed in a plurality of continuous lines surrounding the display region, and the total of the widths of overlaps between the sealing material and the transparent conductive oxide film formed in the plural continuous lines is 100 μm or more.

8. The liquid crystal display device according to claim 1, wherein the area of an overlap between the transparent conductive oxide film and the sealing material is 20% or more of the total bond area on which the sealing material on the TFT-substrate side is bonded to the transparent conductive oxide film.

9. The liquid crystal display device according to claim 1, wherein the alignment film contains a silane coupling agent.

10. The liquid crystal display device according to claim 1, wherein the alignment film is subjected to optical alignment processing.

* * * * *

专利名称(译)	液晶显示装置		
公开(公告)号	US9709854	公开(公告)日	2017-07-18
申请号	US14/720381	申请日	2015-05-22
[标]申请(专利权)人(译)	株式会社日本显示器		
申请(专利权)人(译)	日本展示INC.		
当前申请(专利权)人(译)	日本展示INC.		
[标]发明人	HIROTA TAKENORI KANAYA YASUHIRO SONODA HIDEHIRO KANEKO TOSHIKI		
发明人	HIROTA, TAKENORI KANAYA, YASUHIRO SONODA, HIDEHIRO KANEKO, TOSHIKI		
IPC分类号	G02F1/1339 G02F1/1333		
CPC分类号	G02F1/1339 G02F1/133345 G02F2001/133388		
优先权	2014110118 2014-05-28 JP		
其他公开文献	US20150346556A1		
外部链接	Espacenet USPTO		

摘要(译)

通过以下结构可以提高液晶显示装置的密封部分的可靠性。一种液晶显示装置，包括：TFT基板，包括显示区域和端子部分，并且具有形成在有机钝化膜上的无机绝缘膜和形成在无机绝缘膜上的取向膜；对置基板，TFT基板和对置基板通过形成在围绕显示区域的密封部分的密封材料粘合在一起；并且内部密封有液晶。在密封部分处，在无机绝缘膜和取向膜之间形成透明导电氧化物膜。透明导电氧化物膜存在于TFT基板的边缘内，因此，TFT基板的边缘没有透明导电氧化物膜。

